

## Electronic Patent Application Fee Transmittal

Application Number:	10536621			
Filing Date:	26-May-2005			
Title of Invention:	Polishing pad and method of producing semiconductor device			
First Named Inventor/Applicant Name:	Masahiko Nakamori			
Filer:	Daniel E. Altman/Hiroko Isetani			
Attorney Docket Number:	UNIU40.005APC			

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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**Basic Filing:**

**Pages:**

**Claims:**

**Miscellaneous-Filing:**

**Petition:**

**Patent-Appeals-and-Interference:**

Filing a brief in support of an appeal	1402	1	540	540
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**Post-Allowance-and-Post-Issuance:**

**Extension-of-Time:**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>540</b>